



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Re Patent Application of

Jung-hyun Lee et al.

Application No.: 10/797,046

Filed: March 11, 2004

For: METHOD FOR MANUFACTURING  
OXIDE FILM HAVING HIGH  
DIELECTRIC CONSTANT,

) **MAIL STOP AMENDMENT**

)  
) Group Art Unit: 2811

)  
) Examiner: SARA W CRANE

)  
) Confirmation No.: 4688

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed November 30, 2007, please amend the above-identified application as follows. A two-month extension of time has been requested and the corresponding fee paid extending the time period of response until April 30, 2007.